



3723
PATENT
ERW

Atty. Dkt. No. AMAT/5765/PPC/CMP/AG

In re Application of:
Li, et al.

Serial No.: 10/026,854

Confirmation No.: 1816

Filed: December 20, 2001

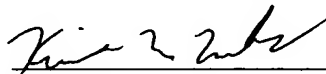
For: Articles for Polishing
Semiconductor Substrates

Group Art Unit: 3723

Examiner: Alvin J. Grant

MAIL STOP AMENDMENT
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

CERTIFICATE OF MAILING 37 CFR 1.8	
I hereby certify that this correspondence is being deposited on June 24, 2005 with the United States Postal Service as First Class Mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.	
June 24, 2005 Date	 Signature

RESPONSE TO OFFICE ACTION DATED MARCH 24, 2005

In response to the Office Action dated March 24, 2005, having a shortened statutory period for response set to expire on June 24, 2005, please enter this response and reconsider the claims pending in the application for reasons discussed below. Although Applicant believes that no additional fees are due in connection with this response, the Commissioner is hereby authorized to charge counsel's Deposit Account No. 20-0782/AMAT/5765/KMT, for any fees, including extension of time fees or excess claim fees, required to make this response timely and acceptable to the Office.

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper. **Remarks** begin on page 8 of this paper.